

<b>Notice of References Cited</b>		Application/Control No. 10/563,993	Applicant(s)/Patent Under Reexamination REICHENBACH ET AL.	
		Examiner PUNAM PATEL	Art Unit 2855	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A US-4,021,766 A	05-1977	Aine, Harry E.	338/2
*	B US-5,521,123 A	05-1996	Komatsu et al.	438/64
*	C US-5,729,019 A	03-1998	Krafthefer et al.	250/353
*	D US-5,841,137 A	11-1998	Whitney, Julie G.	250/338.5
*	E US-6,652,452 B1	11-2003	Seifert et al.	600/140
*	F US-2006/0063292 A1	03-2006	Landsberger, LeslieM	438/051
*	G US-7,402,453 B2	07-2008	Derderian et al.	438/64
H	US-			
I	US-			
J	US-			
K	US-			
L	US-			
M	US-			

**FOREIGN PATENT DOCUMENTS**

*	Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
N	WO 2004114403 A1	12-2004	World Intellect	LUDWIG et al.	H01L 23/31
O					
P					
Q					
R					
S					
T					

**NON-PATENT DOCUMENTS**

*	Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)	
U	G. R. Lahiji and K. D. Wise, "A batch-fabricated Silicon Thermopile Infrared Detector", IEEE Transactions on Electron Devices, Vol. ED-29, No. 1, 1982	
V		
W		
X		

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a))  
Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.